

Special Issue

Multimedia Steganography and Watermarking in the AI Era: Methods, Robustness and Applications

Message from the Guest Editors

As multimedia technologies continue to rapidly evolve, the fields of steganography and watermarking are expanding in both technical depth and their breadth of applications. From copyright protection and tamper detection to covert communication and digital forensics, there is a growing demand for secure, adaptive, and explainable techniques across visual, audio, textual, and multimodal content. With the rise of artificial intelligence—particularly deep learning, generative models, and representation learning—researchers are rethinking the foundations of multimedia steganography and watermarking. At the same time, traditional signal processing, frequency-domain embedding, and cryptographic approaches remain vital to achieving interpretability, controllability, and robustness in real-world settings. This Special Issue will capture the state of the art in multimedia steganography and watermarking in the AI era, with balanced emphases on theory, models, robustness, and applications. We welcome contributions focusing on both AI-powered and conventional approaches that advance security, resilience, and effectiveness in multimedia steganography, watermarking, and data hiding.

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